

Docket No.: 50090-306

AF 12823
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

Primary Application of

Hiroshi TOBIMATSU, et al.

Serial No.: 09/910,824

Filed: July 24, 2001

Customer Number: 20277

Confirmation Number: 3928

Group Art Unit: 2823

Examiner: LEE, Hsien Ming

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING
PASSIVATION FILM AND BUFFER COATING FILM

NOTICE OF APPEAL
FROM THE PRIMARY EXAMINER
TO THE BOARD OF APPEALS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant(s) hereby appeal(s) to the Board of Appeals from the decision dated June 18, 2003
of the Primary Examiner finally rejecting claims 1 through 4 and 6.

Appeal Fee: \$330.00

- ☐ Not required (fee paid in prior appeal in this application).
☒ Charge to Deposit Account No. 500417.
☐ Check Enclosed.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

for/ *Reg* 42,912
Arthur J. Steiner
Registration No. 26,106

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Date: October 17, 2003